

EAST Search Results Case No. 10/698,563

US 6046840 A	USPAT	Double substrate reflective spatial light modulator with self-limiting micro-mechanical elements	359/291
US 6452712 B2	USPAT	Method of manufacturing spatial light modulator and electronic device employing it	359/291
US 6523961 B2	USPAT	Projection system and mirror elements for improved contrast ratio in spatial light modulators	353/99
US 6535319 B2	USPAT	Free-space optical wavelength routing element based on stepwise controlled tilting mirrors	359/225
US 6650461 B2	USPAT	Method of manufacturing spatial light modulator and electronic device employing it	359/291
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US 6741383 B2	USPAT	Deflectable micromirrors with stopping mechanisms	359/291
US 6781742 B2	USPAT	Digital micromirror device and method of driving digital micromirror device	359/290
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US 6844959 B2	USPAT	Spatial light modulators with light absorbing areas	359/297
US 6862127 B1	USPAT	High performance micromirror arrays and methods of manufacturing the same	359/291
US 6867897 B2	USPAT	Micromirrors and off-diagonal hinge structures for micromirror arrays in projection displays	359/291
US 6888521 B1	USPAT	Integrated driver for use in display systems having micromirrors	345/84
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US 6931171 B2	USPAT	Micromirror actuator and manufacturing method thereof	385/18
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US 6970281 B2	USPAT	Micromirror array having reduced gap between adjacent micromirrors of the micromirror array	359/290
US 6975444 B2	USPAT	Double substrate reflective spatial light modulator with self-limiting micro-mechanical elements	359/291
US 6980349 B1	USPAT	Micromirrors with novel mirror plates	359/291
US 6987599 B2	USPAT	Pattern generator mirror configurations	359/290
US 6999228 B2	USPAT	Micro mirror device with adjacently suspended spring and method for the same	359/295
JP 2003156699 A	JPO	MOVABLE MIRROR DEVICE AND PROJECTOR ADOPTING THE SAME	
US 20020051096 A1	US-PGPUB	Digital micromirror device and method of driving digital micromirror device	348/771

US 20050231788 A1	US-PGPUB	MICROMIRROR ARRAY HAVING REDUCED GAP BETWEEN ADJACENT MICROMIRRORS OF THE MICROMIRROR ARRAY	359/290
US 20050231789 A1	US-PGPUB	MICROMIRROR HAVING REDUCED SPACE BETWEEN HINGE AND MIRROR PLATE OF THE MICROMIRROR	359/290
US 20060018003 A1	US-PGPUB	Micromirror and post arrangements on substrates	359/290
US 20060033897 A1	US-PGPUB	Apparatus for forming pattern	355/53
US 20060033977 A1	US-PGPUB	Micromirror device	359/245
US 20030118278 A1	US-PGPUB	Micromirror actuator and manufacturing method thereof	385/18